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FORM
(to be used for all correspondence after initial filing)

Application Number	09/836,449	· · · · · ·
Filing Date	April 17, 2001	<u> </u>
First Named Inventor	Stephen J. Fonash	
Group Art Unit	2812	
Confirmation No.	7746	
Attorney Docket Number	201009-007000	

	<u> </u>		7740			
Total Number of Pages in This Submission	n	Attorney Docket Number	201009-007000			
ENCLOSURES (check all that apply)						
Fee Transmittal Form Fee Attached Amendment After Final Affidavits/declaration(s) Extension of Time Request for_ month Express Abandonment Request X Information Disclosure Statement Form PTO 1449 w/4 refs. Certified Copy of Priority Document(s)	Assignm (for an A) Submiss Drawing Declara Licensin Petition Applica Power of Change Termina Request	nent Papers Application) Sion Of Corrected Substitute gs tion and Power of Attorney ng-related Papers to Convert to a Provisional	 □ After Allowance Communication to Group □ Appeal Communication to Board of Appeals and Interferences □ Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) □ Proprietary Information □ Status Letter □ Application Data Sheet □ Request for Corrected Filing Receipt with Enclosures □ A self-addressed prepaid postcard for acknowledging receipt ☑ Supplementary Partial European Search Report 			
Response to File Missing Parts of Nonprovisional Application Formalities Let Response to Missing Parts under 37 CFR 1.52 or 1.53	er Remarks	Remarks The Commissioner is hereby authorized to charge any additional fees required or credit any overpayments to Deposit Account No. 19-2380 for the above identified docket number.				
SIGN.	ATURE OF APPL	ICANT, ATTORNEY, O	PR AGENT			
Individual name Nixon 401 9 Suite	J. Hawranek, Reg Peabody LLP Street, N.W. 900 ngton, D.C. 200					
Signature	14/17/					
Date Augus	Sid of which					
CERTIFICATE OF MAILING OR TRANSMISSION [37 CFR 1.8(a)] I hereby certify that this correspondence is being: deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop Missing Parts, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450 transmitted by facsimile on the date shown below to the United States Patent and Trademark Office at (703) 872-9306						
Date		Туре	Signature ed or printed name			

Docket No.: 201009-007000

N THE LINITED STATES PATENT AND TRADEMARK OFFICE

) Art Unit: 2812

In re Patent Application of

Stephen J. FONASH) Confirmation: 7746

Application No.: 09/836,449

Filed: April 17, 2001) Date: August 3, 2005

For: DEPOSITED THIN FILMS AND THEIR

USE IN SEPARATION AND SACRIFICIAL

LAYER APPLICATIONS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form be returned to the undersigned.

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

By:

Scott J. Hawranek

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INFO	DMATION I) icc		Application Number	09/836,449	
INFORMATION DISCLOSURE				Filing Date	April 17, 2001	
51A	STATEMENT BY APPLICANT			First Named Inventor	Stephen J. FONASH	
(use as many sheets as necessary)				Group Art Unit	2812	
				Examiner Name	Richard A. Booth	
Sheet	1	of	1	Attorney Docket Number	201009-007000	

U.S. PATENT DOCUMENTS						
Cite No.1	U.S. Patent Document		Name of Patentee or Applicant of Cited	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
			Document	MM-DD-YYYY		
	5,594,171		Ishida et al.	January 14, 1997		
1						
 						
		No. ¹ Number Ki	No. ¹ Number Kind Code ² (if known)	Cite No. 1 U.S. Patent Document Name of Patentee or Applicant of Cited	Cite No. 1 Number Kind Code 2 (if known) Name of Patentee or Applicant of Cited Document Name of Patentee or Applicant of Cited Document MM-DD-YYYY	

				F(DREIGN PATENT DOC	UMENTS			
Examiner Initials*	Cite No. ¹	Foreign Patent Document Kind Code ⁵ Office ³ Number ⁴ (if known)			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T _Q	
			EP 0 895 276 A	A1	Bruno Murari	March 2, 1999			
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			ОТН	ER PRIOR	ART – NON PATENT LITE	RATURE DOCUMENTS			
					thor (in CAPITAL LETTERS), title of the article (when appropriate), title of the ournal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.				
	Supplementary Partial European Search Report					,			
	FURUKAWA, et al. Nickel Surface Micromachining, Sixth International Symposium on Micro Machine and Human Science, 1995, pp. 161-165, IEEE. WALTER LANG, Silicon Microstructuring Technology, Materials Science and Engineering, Reports: A Review Journal R17 (1996), pp. 1-55.								

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.